

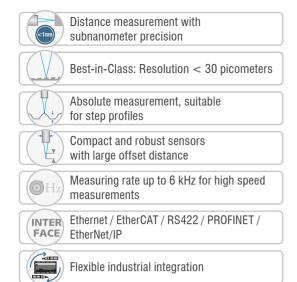
More Precision

interferoMETER // High precision absolute interferometers



Absolute distance measurements with subnanometer resolution

interferoMETER 5600





Designed for high-resolution distance measurements in clean rooms & vacuums

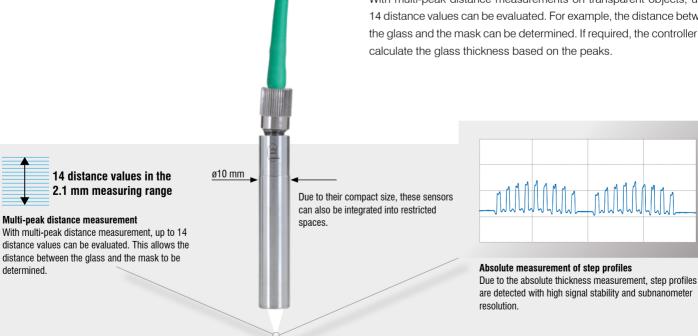
The IMS5600-DS absolute interferometer is used for distance measurements with maximum precision. The controller offers a special calibration with intelligent evaluation and enables absolute measurements with subnanometer resolution. This includes measurement tasks with the highest accuracy requirements, for example in electronics and semiconductor production. For vacuum applications, Micro-Epsilon offers special sensors, cables and feedthrough accessories. These sensors and cables are particle-free to a high degree and can even be used in UHV.

Absolute distance measurements with a large measuring range and offset distance

The IMS5600-DS system is used for high-precision displacement and distance measurements. The system provides absolute measurement values and can therefore also be used for distance measurement of step profiles. Thanks to the absolute measurement, sampling is performed without signal loss. When measuring on moving objects, the differences in height of heels, steps and depressions can thus be reliably detected. The measuring system offers sub-nanometer resolution with a large offset distance in relation to the measuring range.

Multi-peak distance measurement

With multi-peak distance measurements on transparent objects, up to 14 distance values can be evaluated. For example, the distance between the glass and the mask can be determined. If required, the controller can



Controller

Model		IMS5600-DS	IMS5600MP-DS		
Resolution [1]		< 30 pm			
Measuring rate		continuously adjustable from 100 Hz to 6 kHz			
Linearity [2]		< ±10 nm	$<\pm 10$ nm for the first distance; $<\pm 100$ nm for each further distance		
Temperature stability		temperature compensated, stability $<$ 10 ppm between +15 +35°C			
Multi-peak measurement		-	up to 13 layers		
Light source		NIR-SLED, narrow wavelength band at approx. 84	NIR-SLED, narrow wavelength band at approx. 840 nm; pilot laser: laser LED, wavelength 635 nm		
Laser class		Class 1 according to DIN EN 60825-1: 2015-07; Pilot laser: Class 1, power (< 0.2 mW)			
Supply voltage		24 VDC ±15 %			
Power consumption		approx. 10 W (24 V)			
Signal input		Sync in, trigger in, 2x encoders (A+, A-, B+, B-, index)			
Digital interface		Ethernet / EtherCAT / RS422 / PROFINET / EtherNet/IP [3] / EtherNet/IP [3]			
Analog output		4 20 mA / 0 10 V (16 bit D/A converter)			
Switching output		Error1-Out, Error2-Out			
Digital output		sync out			
Connection	Optical	Pluggable fiber optic cable via E2000 socket (bending radius: static 3	(controller); see accessories for cable lengths; 10 mm, dynamic 40 mm		
	Electrical	3-pin supply terminal strip; encoder connection (15-pin, HD-sub st RS422 connection socket (9-pin, Sub-D, max. cable length 11-pin I/O terminal strip (max. cable length 30 m); RJ45 socket	30 m); 3-pin output terminal strip (max. cable length 30 m);		
Mounting		Sensor via radial clamping or mounting adapter (see acce	essories); controller free-standing or top-hat rail mounting		
T .	Storage	-20 +70 °C			
Temperature range	Operation	+15	+35 °C		
Shock (DIN EN 60068-2-27)		15 g / 6 ms in XY axis	15 g / 6 ms in XY axis, 1000 shocks each		
Vibration (DIN EN 60	0068-2-6)	2 g / 20 500 Hz in XY axis, 10 cycles each			
Protection class (DIN EN 60529)		IP40			
Material		Aluminum housing, passive cooling			
Control and indicator elements		Multifunction button: two adjustable functions and reset to factory settings after 10 s; web interface for setup: selectable presets, freely selectable averaging, data reduction, setup management; 6 x color LEDs for intensity, range, SLED, pilot laser, status and power; pilot laser: can be switched on for sensor alignment			

All data at constant ambient temperature (24 \pm 2 °C). Measuring rate 0.5 kHz, moving average over 64 values, measured differentially between the front and back of a thin glass plate in the mid of the measuring range (2 sigma) [1]

Maximum deviation from reference system over the entire measuring range, measured on front surface of ND filter

Optional connection via interface module (see accessories)

Sensors for distance measurements interferoMETER 5400-DS/5600-DS



Sensors for the IMS5400 / IMS5600 controllers for distance measurement

Model		IMP DS1/VAC	IMP DS0.5/90/VAC	IMP DS10/90/VAC	IMP DS19	
Measuring range	Distance	1 mm	1.5 mm	1.5 mm	2.1 mm	
	Thickness [1]	0.01 0.7 mm	0.01 1.0 mm	0.01 1.0 mm	0.01 1.3 mm	
Start of measuring ran	nge	1 mm	0.5 mm	10 mm	19 mm	
Temperature stability		Linearity: typ. 0.1 nm / K (without offset shift)				
Light spot diameter [2]		10 µm				
Measuring angle [3]		±2°				
Target material		Glass, reflecting or diffuse surfaces [4]				
Connection	Optical	Sensor with integrated vacuum optical fiber; length 2 m and FC/APC connector. Extension via pluggable optical fiber FC socket (vacuum feedthrough); cable lengths see accessories; bending radius: static 30 mm, dynamic 40 mm	Pluggable fiber optic cable via FC socket (vacuum feedthrough); pluggable UHV fiber optic cable via FC socket (feedthrough and sensor with vacuum capability); cable lengths see accessories; bending radius: static 30 mm, dynamic 40 mm			
Mounting		Radial clamping, mounting adapter (see accessories)				
Tomporatura rango	Storage	-20 +70 °C				
Temperature range	Operation	+5 +70 °C				
Dimensions	Diameter	Ø4	Ø10	Ø10	Ø10	
Differsions	Length	23 mm	approx. 78.1 mm	approx. 68.6 mm	55 mm	
Protection class (DIN EN 60529)		IP40	IP40	IP40	IP65; IP40 (option/VAC)	
Vacuum		UHV (cable and sensor)	UHV (cable and sensor)	UHV (cable and sensor)	Optional UHV (cable and sensor)	
Material		Stainless steel	Stainless steel	Stainless steel; optional: titanium housing	Stainless steel; optional: Invar housing	

^[1] Application for MP measurement

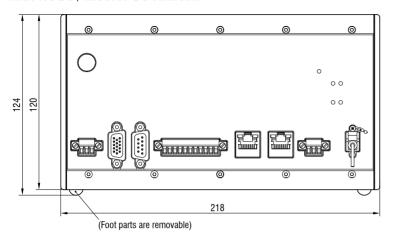
 $^{^{[2]}}$ All data at constant ambient temperature (24 ± 2 °C). In the mid of the measuring range

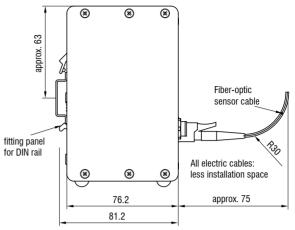
^[3] Maximum sensor tilt angle that produces a usable signal on polished glass (n = 1.5) in the mid of the measuring range. The accuracy decreases when approaching the limit values.

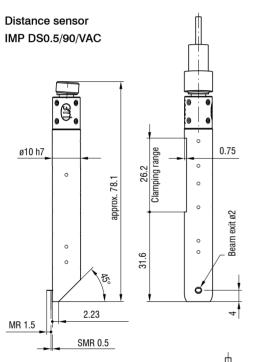
^[4] Non-transparent materials require optically dense surface at a wavelength of 840 nm

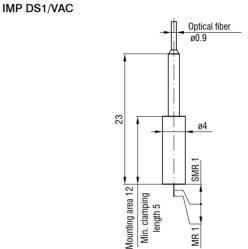
Dimensions

IMS5400-DS / IMS5600-DS controller

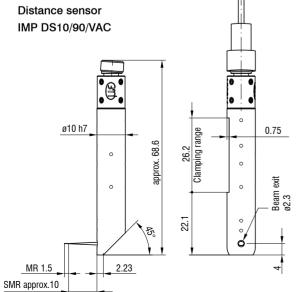


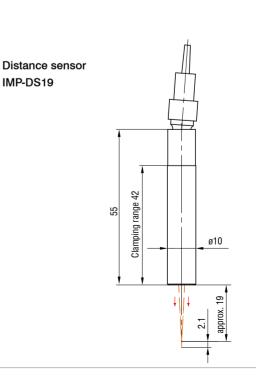






Distance sensor

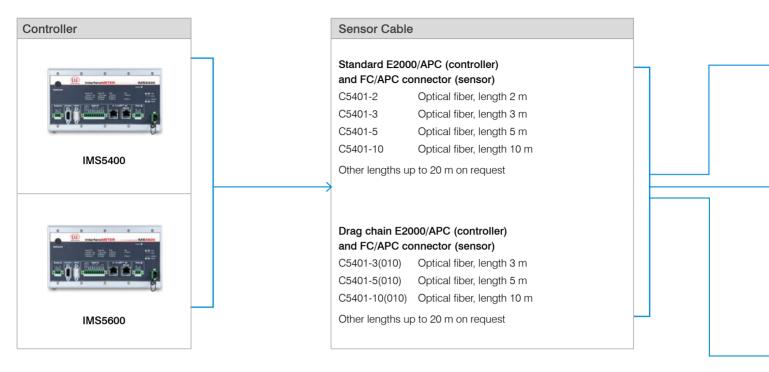




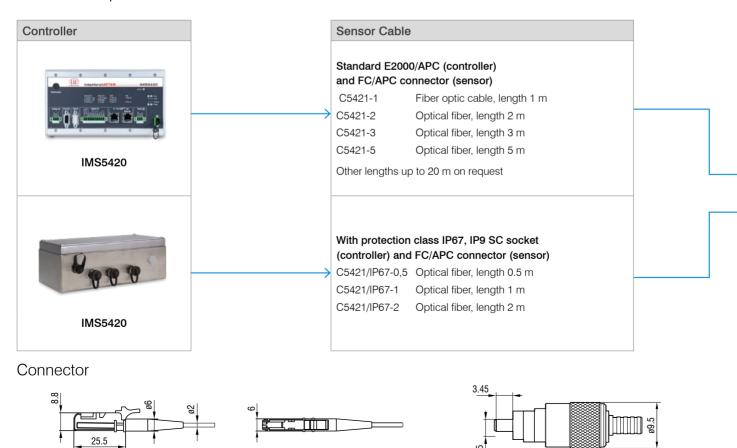
Connection possibilities

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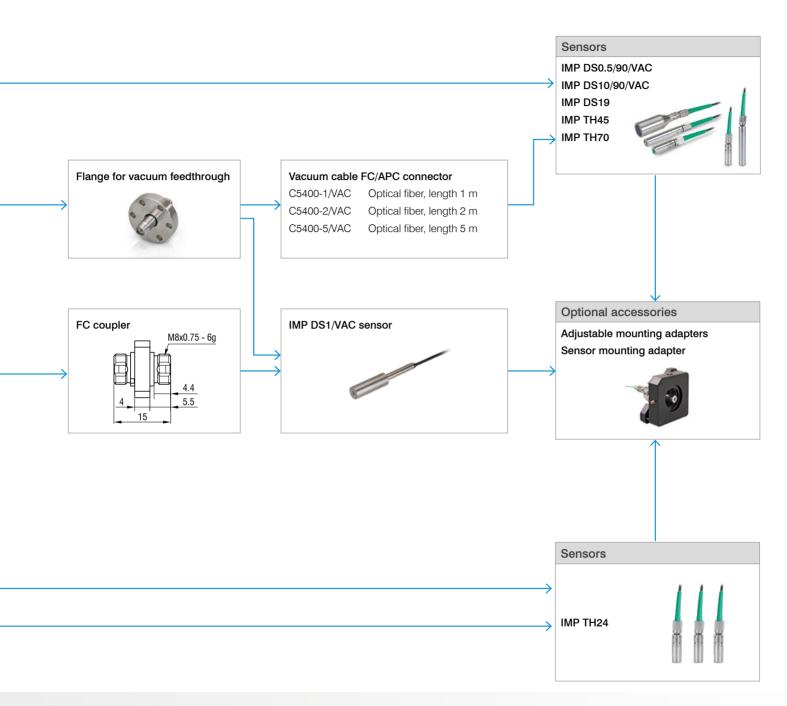
Connection options for the IMS5400 and IMS5600 controllers



Connection options for the IMS5420 controller



FC/APC Standard connector



Article designations



IMS5xxx-DSxx distance measuring system (e.g. IMS5600MP-DS19)

IMS5xxx	-DSxx		
Controller model	Sensor model		
IMS5400	DS1/VAC		
IMS5400MP	DS19		
IMS5600	DS19/VAC		
IMS5600MP	DS0.5/90/VAC		
	DS10/90/VAC		



IMS5xxx-THxx thickness measuring system (e.g. IMS5400-TH45/VAC)

IMS5xxx	-THxx		
Controller model	Sensor model		
IMS5400	TH45		
IMS5400MP	TH45/VAC		
	TH70		



IMS5420xx-THxx wafer thickness measuring system (e.g. IMS5420-TH24)

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Optional accessories

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Flange for vacuum feedthrough

C5405/VAC/1/CF16 CF flange C5405/VAC/1/KF16 KF flange

Mounting adapter

MA5400- 10 Mounting adapter for IMP-DS19/ -TH45

MA5400- 20 Mounting adapter for IMP-TH70 MA2402-4 Mounting adapter for IMP-DS1

Other accessories

SC2471-x/IF2008 IMC5400/5600 connector cable+ IF2008/PCIE, length 3 m / 10 m SC2471-x/RS422/OE IMC5400/5600 interface cable + IF2001/USB, length 3 m / 10 m

IF2001/USB RS422/USB converter

IF2008/PCIE Interface card

IF2035/PNET Interface module for PROFINET integration

IF2035-EIP Interface module for EtherNet/IP with DIN rail housing

PS2020 Power supply 24V / 2.5A EC2471-3/OE Encoder cable, 3 m

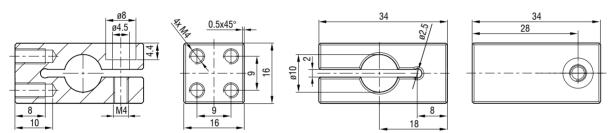


C5405/VAC/1/CF16 C5405/VAC/1/KF16

Sensor mounting adapter

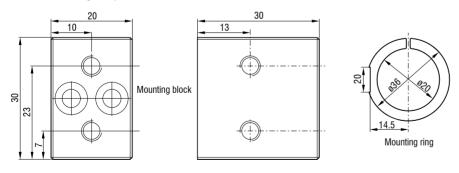
MA5400-10

Sensor mounting adapter for all interferoMETER sensors: (exception IMP-DS1, IMP-TH70)



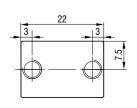
MA5400-20

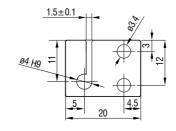
Sensor mounting adapter for IMP-TH70 sensors:

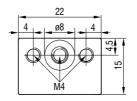


MA2402-4

Sensor mounting adapter for IMP-DS1 sensors



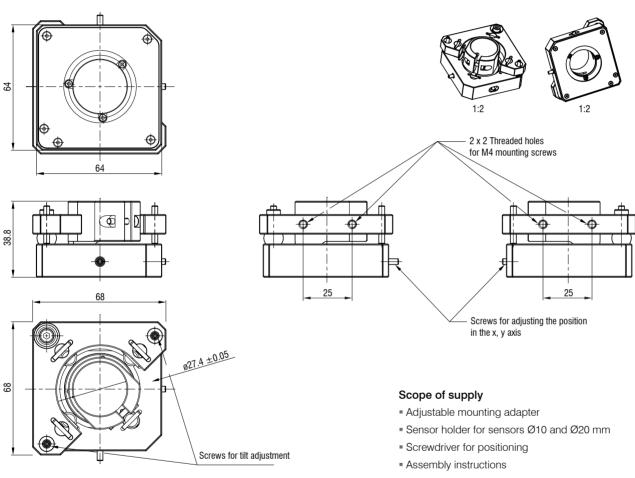




Adjustable mounting adapter

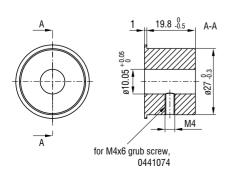
The adjustable JMA mounting adapter simplifies the alignment and fine adjustment of interferometric sensors. The sensors and adapters can be integrated into the machine and aligned directly on site. This corrects, e.g., minor deviations caused by mounting and compensates for tilted measuring objects. With two-sided thickness measurements, the mounting adapter supports the fine alignment of the two measuring points.



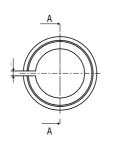


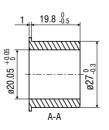
Sensor holder

Sensor holder for JMA-10



Sensor holder for JMA-20





(dimensions in mm, not to scale)

Sensors and Systems from Micro-Epsilon



Sensors and systems for displacement, distance and position



Sensors and measurement devices for non-contact temperature measurement



Measuring and inspection systems for metal strips, plastics and rubber



Optical micrometers and fiber optics, measuring and test amplifiers



Color recognition sensors, LED analyzers and inline color spectrometers



3D measurement technology for dimensional testing and surface inspection